



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s):	Luu, et al.	Attorney Docket No.:	SIGLAZ-P007
Serial No.:	10/765,505	Group Art Unit:	2812
Filed:	01/26/2004	Examiner:	Stevenson, Andre C
Title:	Automated Sourcing of Substrate Microfabrication Defects Using Defect Signatures		

**AMENDMENT A**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated June 20<sup>th</sup>, 2006, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of Claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.